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GP 1765

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Hiroto OHTAKE, et al.

Appln. No.: 10/080,848

: Art Unit: 1765

Filed: February 22, 2002

: Examiner: DEO, Duy Vu Nguyen

For: **METHOD OF MANUFACTURING A
SEMICONDUCTOR DEVICE
CAPABLE OF ETCHING A MULTI-
LAYER OF ORGANIC FILMS AT A
HIGH SELECTIVITY**

: Docket No.: KRM-00101

CERTIFICATE OF MAILING

I hereby certify that the foregoing document is being deposited with the United States Postal Service as first class mail, postage prepaid, "Post Office to Addressee", in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA, 22313-1450 on April 8, 2004.



Tracey A. Newell

RESPONSE TO ELECTION/RESTRICTION

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated March 16, 2004, in which election of species was required, Applicant elects Group II, Claims 20-29 that are drawn to a product.

Favorable consideration and allowance are earnestly solicited. Should there be any questions after reviewing this paper, the Examiner is invited to contact the undersigned at 617-248-4038.

Respectfully submitted,
CHOATE/HALL & STEWART



Donald W. Muirhead
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Date: April 8, 2004

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